

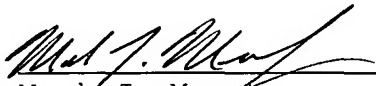


The citation of the above-discussed documents is not to be construed as an assertion that more pertinent art could not possibly be in existence. Citation of any document herein is not to be construed as an admission that any subject matter disclosed in the document is necessarily within the inventive field of endeavor, that any disclosure is necessarily prior in time to a particular date which may be relevant to the instant patent application, and/or that any disclosure is otherwise necessarily prior art with respect to the instant invention.

Applicant also respectfully reserves the right to later set forth how the instant invention is distinguished over the disclosure of any document or other art, including the disclosure of those documents discussed herein, that may be cited by the Examiner in rejecting a claim in the instant patent application.

A first office action, notice of allowance or issue fee notification has not been received in this case, so applicant does not believe that a fee is due. However, if any such fee is required, please charge our Deposit Account No. 50/1039.

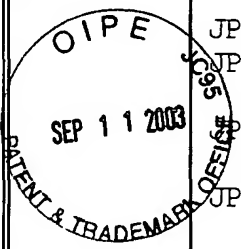
Respectfully submitted,

  
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LIST OF PUBLICATIONS CITED BY APPLICANT			<u>Atty. Docket No.</u> 0553-0184.01	<u>Serial No.</u> 10/642,803		
			<u>Applicant</u> Shunpei YAMAZAKI et al			
			<u>Filing Date</u> August 18, 2003	<u>Group</u>		
U.S. PATENT DOCUMENTS						
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
	5,463,483	10/31/95	Yamazaki	359	58	03/30/93
	5,485,019	01/16/96	Yamazaki et al	257	57	02/03/93
	5,576,857	11/09/96	Takemura	359	59	03/30/93
	5,595,638	01/21/97	Konuma et al	205	96	03/10/95
	5,643,826	07/01/97	Ohtani et al	437	88	10/25/94
	5,650,636	07/22/97	Takemura et al	257	59	06/01/95
	5,712,495	01/27/98	Suzawa	257	51	03/10/97
	5,729,308	03/17/98	Yamazaki et al	349	39	02/15/96
	5,757,444	05/26/98	Takemura	349	38	07/01/97
	5,763,899	06/09/98	Yamazaki et al	257	59	02/07/96
	5,777,713	07/07/98	Kimura	349	156	06/17/96
	5,847,687	12/08/98	Hirakata et al	345	96	03/24/97
	5,849,611	12/15/98	Yamazaki et al	438	151	05/31/95
	5,852,488	12/22/98	Takemura	349	187	12/22/95
	5,856,689	01/05/99	Suzawa	257	296	10/31/97
	5,923,962	07/13/99	Ohtani et al	348	150	04/28/95
	5,929,464	07/27/99	Yamazaki et al	257	72	01/19/96
	5,959,599	09/28/99	Hirakata	345	92	11/04/96
	5,977,562	11/02/99	Hirakata et al	257	72	11/14/96
	5,995,186	11/30/99	Hiroshi	349	141	04/04/97
	5,998,841	12/07/99	Suzawa	257	350	10/05/98
	6,013,930	01/11/00	Yamazaki et al	257	353	09/22/98
	6,100,947	08/08/00	Katayama	349	38	06/04/98
	6,165,824	12/26/00	Takano et al	438	160	03/03/98
	6,344,884 B1	02/05/02	Kim et al	349	43	11/25/98

FOREIGN PATENT DOCUMENTS						
	DOCUMENT NUMBER	DATE	NAME	English Abstract	English Trans.	FILING DATE
	JP 6-160878	06/07/94	Hitachi Ltd.	X		09/10/93
	JP 7-130652	05/19/95	Semiconductor	X		10/29/93
	JP 9-211477	08/15/97	Energy Lab Co. Ltd.	X		01/31/96
	JP 9-211495	08/15/97	Semiconductor	X		01/31/96
	JP 10-247735	09/14/98	Energy Lab Co. Ltd.	X		03/03/97
	JP 2000- 122071 A	04/28/00	Semiconductor			10/13/98
			Energy Lab Co. Ltd. Yamada et al			
OTHER PRIOR ART - NON-PATENT LITERATURE DOCUMENTS (Including Author, Title, Date, Pertinent Pages)						
	SHIMOKAWA, R. et al, "Characterization of High-Efficiency Cast-Si Solar Cell Wafers by MBIC Measurement," Japanese Journal of Applied Physics, vol. 27, no. 5, pp. 751-758, May (1988).					
EXAMINER:				DATE CONSIDERED:		
*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP form. Draw line through citation if not in conformance and not considered. Include a copy of this form with the next communication to applicant.						